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Simulation of grain evolution in solidification of silicon on meso-scopic scale

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Abstract

We present a cellular automata model for computing the grain evolution during directional solidification of silicon on a meso-scopic scale. Firstly, the method is applied to test cases with different shapes of the melt/crystal interface. In a second step we compute the case of an experiment with in-situ observation of the interface shape evolution [1]. Here we also include the effect of twinning. The interchanging appearance of two twins could be revisited by our calculations. The probabilities used correspond to those which were analytically derived for an undercooling of $\Delta T = 0.6~K$ [29]. This undercooling is a typical value for a groove with $\langle 111 \rangle$ facets [34].

Keywords: Directional Solidification; Multicrystalline Silicon; Cellular Automata; Lattice Boltzmann Methods;

1. Introduction

Grain evolution is one of the key issues during the directional solidification of multi-crystalline silicon (mc-Si) for photovoltaic applications, because the final grain structure and related defects of silicon ingots strongly influence the conversion efficiency of solar cells [2]. Generally, defects such as grain boundaries (GBs), impurity segregation and dislocations prevent the formation of homogeneous grain structure of mc-Si ingots. Once a mc-Si ingot is obtained by casting, it is hard to drastically change its grain structure in the solid state. Therefore, it is necessary to gain a better understanding of the grain evolution during the solidification process and thus control the final grain arrangement. For this reason, fundamental studies for the grain growth have come into focus recently.

Generally, grain competition is one of the key mechanisms for the evolution of the grain structure. Influence of growth conditions on the grain competition in mc-Si has been investigated from both experimental and theoretical viewpoints [3, 4, 5]. More specifically, the shape of GB groove at the triple junction of grain-grain-melt is the determining factor for which grain will grow faster than the others in the solidification growth, as explained by theoretical studies [6] and simulation results [7]. In the latter numerical studies it was also shown that the temperature field around a groove adapt to the situation of strongly curved melt/solid interfaces and growth kinetics. The temperature gradient in the groove and its vicinity is different from the avarage one at the interface.

On the other hand, changes of grain structure will also occur due to the GBs interaction in the growth process. GB interactions during the growth process include GB generation and annihilation, which will lead to variation of the total number of GBs, grain sizes and GB types. Experimental research revealed that the majority of GBs in pure samples originated from $\Sigma 3$ twins (Σ boundaries are boundaries where atoms of the two grain coincides after a certain period), and that the interaction between Σ twinned grains is dominant during the grain evolution process [8, 9, 10]. On the microscopic scale, phase field methods have been applied to compute grain growth [11]. Phase field methods are an important technique for investigating the details of grain evolution in direct solidification of Si including the effects of interface curvature but they are quite time consuming and thus unable to calculate the soldification on the typical time scale for silicon (hours).

Despite of the ongoing investigations of the grain growth during the solidification of mc-Si, the work on the modeling and simulation of the grain evolution on the macroscopic scale is still a challenge due to the complexity of multi-scale modeling. Some attempts have been made to study the grain structure on the macroscopic scale [12, 13], in which only simplified geometrical rules for the evolution of GBs were applied. Cellular automata (CA) methods are widely used for computation of grain evolution [14, 15]. Rappaz et al. were the first using this kind of methods to predict the solidification of grain structures [16]. Recently, several researchers have been simulated the nucleation and crystalline structure formation for mc-Si by employing CA and finite element models in the commercial software ProCAST [17, 18, 19]. CA are mesoscale methods, which can efficiently bridge the gap between micro- and macroscopic scale calculations, allowing the simulation of a large-scale crystal growth. However, the CA method usually ignores some details in the microscopic simulation method, such as anisotropy and faceting.

We have developed a two dimensional (2D) model, which uses input data based on results of calculation on the microscopic scale, taking into account the details of growth kinetics and interfacial energy effects [3, 7]. The phase transition is computed by using a sharp interface model and a CA method is employed to calculate the grain orientation. We are going beyond the typical approaches of CA methods and take into account results of microscopic calculations and of dedicated experiments to set the rules of grain growth competition. Microscopic calculations in this contexts mean computations covering the details in the groove and at the multiple phase junctions between melt and grains including the curvature effects on undercooling. We perform such computations by employing the phase field method introduced by Kobayashi et al. [20] (see

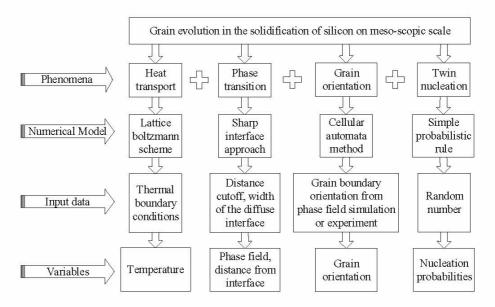


Figure 1: Schematic of different phenomena, numerical model, input data and variables for grain evolution.

e.g. [7]). In particular, the input data consists of the GB orientations with respect to the interface normal for every combination of GBs, are taken from microscopic calculations or dedicated experimental results. By using this approach combining CA, a sharp interface model, and input data, we can consider effects interfacial energies, growth kinetics and their anisotropies in large scale simulations. As a preliminary example, we restrict our computations to 2D cases and investigate the influence of the crystal/melt interface shape on the grain evolution. Furthermore, the numerical model is extended to calculate the nucleation of twin seeds at the crystal/melt interface. This model enables us to compute the grain evolution as observed in experiments with in-situ X-ray imaging observation [9].

2. Numerical Method

The keypoint of the algorithm is the computing of the phase transition by a sharp interface approach on a fixed grid, i.e. the interface is located between grid points, and a cellular automata (CA) for updating the grain orientation. The rules for the CA are kept simple but complex enough to cover the relevant physics at three phase junctions of melt and two grains. The input parameters for the rules are taken from the results of microscopic calculations if possible or they are determined from experimental results. A simple probabilistic rule for twin nucleation is also introduced. Fig. 1 shows schematic of different phenomena, numerical model, input data and variables for grain evolution.

2.1. Phase transition and heat transport

We use a hybrid algorithm for computing the phase transition. A sharp interface is used on off-grid points and the movement of the interface is computed by a kinetic operator (see e.g.[21]) to treat the growth kinetics at $\langle 111 \rangle$ facets. The computation of the interface movement is done node-wise and the calculation is local. In order to correlate neighbouring nodes we additionally use a phase field ϕ . The gradient of the phase field $\nabla \phi$ is computed by applying a nine-point stencil finite difference method using all lateral and diagonal neighbours (see e.g. [22]). This ensures the coupling of nodes with respect to the the position of the interface. In particular, the computation of the interface follows these two steps:

- Step 1 If the distance at node $\vec{x}(i, j, k)$ to interface is smaller than a cutoff (10⁻⁵ m), the phase field is updated:
 - (a) Compute the growth direction by $\nabla \phi$.
 - (b) Compute the temperature at interface T_{int} using distance $\tilde{x}(i, j, k)$ and $\vec{n} = \nabla \phi / |\nabla \phi|$.
 - (c) Compute the growth velocity v_n using T_{int} and a kinetic operator.
 - (d) Compute new distance from interface $\tilde{x}(t+\delta t) = \tilde{x}(t) + |v_n|\delta t$.
 - (e) Compute new ϕ : $\phi(t+\delta t)=\frac{1}{2}\left\{1+\tanh\left(\frac{3\tilde{x}(t+\delta t)}{\delta}\right)\right\}$, where δ is the width of the diffuse interface.

Please note that the diffuse interface is only used for computing the interface normal.

Step 2 Update ϕ in cells, where Step 1 was not done but in one of the neighbouring cells.

 $T_{\rm int}$ is computed at an off-lattice point. In the following the details of computing are given taking into account the different thermal conductivities in melt and solid. The geometrical situation is shown in Fig. 2 (a).

The point \vec{x}_{int} on the interface of node $\vec{x}(i,j,k)$, i.e. $\vec{x}_{\text{int}} = \vec{x}(i,j,k) + \tilde{x}(i,j,k)\vec{n}$, lies within a quadrat bounded by *iwest*, *ieast*, *jnorth*, and *jsouth*. The interface line will cross two boundary lines (see Fig. 2 (a)). The temperature at the crossing points x_{c1} and x_{c2} will be computed according to

$$T_{\rm int}(x_{ci}) = \frac{D_T^{\rm s} \Delta x_s T(\vec{x} @ \phi < 0.5) + D_T^{\rm m} \Delta x_m T(\vec{x} @ \phi \ge 0.5)}{D_T^{\rm s} \Delta x_s + D_T^{\rm m} \Delta x_m},$$
(1)

where $\vec{x} @ \phi < 0.5$ and $\vec{x} @ \phi \ge 0.5$ are the nodes in the liquid and solid part, respectively. The temperature at the interface used for the computation of the interface velocity is given by:

$$T_{\text{int}} = \frac{T_{\text{int}}(x_{c1})|\vec{x}_{c2} - \vec{x}_{\text{int}}| + T_{\text{int}}(x_{c2})|\vec{x}_{c1} - \vec{x}_{\text{int}}|}{|\vec{x}_{c2} - \vec{x}_{c1}|}.$$
 (2)

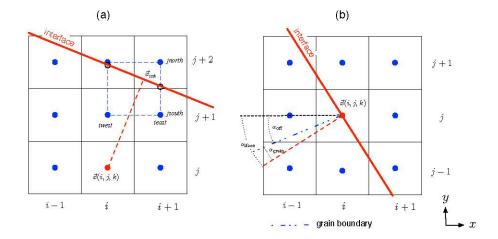


Figure 2: Left (a): Sketch for computing the temperature at the interface for using it to calculate the interface velocity. Right (b): Definition of angles for updating grain orientation.

The heat transport equation

$$\frac{\partial T}{\partial t} = \nabla (D_T \nabla T) + S_L \tag{3}$$

is solved by a Lattice Boltzmann scheme [23]. S_L is the latent heat soruce, which is defined as follows:

$$S_L = \frac{\partial \phi}{\partial t} = \frac{\Delta H_V}{\rho c_p},\tag{4}$$

where ΔH_V , ρ , c_p are the latent heat per volume, the density, and the specific heat, respectively.

The thermal diffusivity at node $\vec{x}(i, j, k)$ is set by:

$$D_T(i,j,k) = D_T^{s}\phi(i,j,k) + D_T^{m}(1 - \phi(i,j,k)),$$
(5)

where D_T^s and D_T^m are the thermal diffusivities in solid and melt, respectively.

2.2. Updating grain orientation

The computational domain in our calculation is a rectangle with a uniform grid. Every grain is given a number and this grain number is unique in a cell. In other words, there the grain orientation is the same in the entire cell and a grain boundary is located on the boundary of the cells and is not off-grid as the interface line. To begin with, we set an artificial initial crystal/melt interface shape and a configuration of grains. In the melt there is no grain orientation and the grain number is set to -1.

We now consider a node at time t with a phase field value $\phi(t) < 0.45$. If $\phi(t) \geq 0.45$ in the next time step (t+1) a grain number has to be attributed

Material parameter		Unit	Value	
Thermal diffusivity in melt	D_T^m	$\mathrm{m^2\cdot s^{-1}}$	2.64×10^{-5}	[24]
Thermal diffusivity in solid	$\bar{D_T^s}$	$\mathrm{m}^2\cdot\mathrm{s}^{-1}$	$0.9 imes 10^{-5}$	[25]
Latent heat	$\Delta \bar{H}_V$	$ m J\cdot m^{-3}$	4.22×10^9	[26]
Specific heat	ρc_p	$ m J \cdot K^{-1} \cdot m^{-3}$	$2.2 imes 10^6$	[27]
Melting-point temperature	T^{i}	${ m K}$	1683	

Table 1: Thermophysical properties of Si used in simulations.

to this node. In order to do so we consider the grains at three adjacent nodes. The choice of the three nodes depends on the local curvature of the interface as depicted in Fig. 3. If α_{iface} (see Fig. 2 (b)) is between $-45^{\circ}/2$ and $+45^{\circ}/2$ we use the three nodes at i-1 (Fig. 3 (a)). If $45^{\circ}/2 < \alpha_{iface} < 45^{\circ} + 45^{\circ}/2$ we use the nodes as indicated in Fig. 3 (b). If $45^{\circ} + 45^{\circ}/2 < \alpha_{iface} < 90^{\circ}$ we use the nodes as indicated in Fig. 3 (c). Currently, we do not allow a growing in negative x-direction. For cases (b) and (c) in Fig. 3 there exist also the corresponding cases with growth direction in +y direction and nodes 1,2 or 0,1,2 at j-1.

When a node $\vec{x}(i,j,k)$ changes from the melt region to solid region in the solidification process, we firstly choose the selection scheme according to the interface normal, as shown in Fig. 3. Then, if all the three neighbour nodes have the same grain number, i.e. belong to the same grain, also the node $\vec{x}(i,j,k)$ belongs to this grain and thus, this grain number is set to the node. If the grains are different, the orientation of GB has to be computed. As the node $\vec{x}(i,j,k)$ has a unique value of grain number, we need a set of rules in the manner of a CA to compute the new value. For every combination of GBs in a run, α_{grain} is stored prior to computation. Please note that the orientation of the grains is measured against the interface normal (dotted red line in Fig. 2). This means that for the same combination of two grains in the meso-scopic calculation α_{grain} depends on α_{iface} and might be quite different in time. As α_{iface} was computed from the phase field and α_{grain} is picked up from the input table for the particular α_{iface} , α_{off} can be computed via

$$\alpha_{\text{off}} = \alpha_{\text{grain}} + \alpha_{\text{iface}}.$$
 (6)

The values for $\alpha_{\rm grain}$ can be determined from experimental results or calculated on microscopic scale as e.g. by phase field simulation [3, 7]. Once $\alpha_{\rm off}$ has been determined, one can compute the probabilities that the node $\vec{x}(i,j,k)$ becomes one or the other grain. The choice is done via a random generator. By definition of the CA the grain boundary is a zig-zag line following the grid with an average inclination equivalent to $\alpha_{\rm off}$. This has been tested for the evolution of a planar interface.

There might be also locally a back melting of the solid. When $\phi(t)$ at a node becomes smaller 0.1 the grain number at this node is set to unknown. Once this node becomes solid again, the grain orientation has to be recomputed.

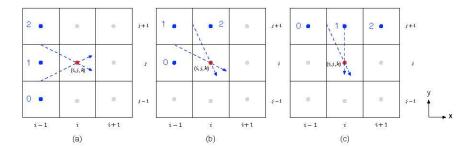


Figure 3: Grain selection schemes in the solidification process according to the curvature of the crystal/melt interface shape. We distinguish three cases depending on the interface shape. The blue dotted lines indicate the extreme values for the interface normals for the case. The blue nodes are the nodes used for computing the grain at the red point (i,j,k). Case (a): $-\frac{45^{\circ}}{2} \geq \alpha_{\text{lface}} \geq \frac{45^{\circ}}{2}$. Case (b): $\frac{45^{\circ}}{2} < \alpha_{\text{lface}} < 45^{\circ} + \frac{45^{\circ}}{2}$. Case (c): $45^{\circ} + \frac{45^{\circ}}{2} < \alpha_{\text{lface}}$. For cases (b) and (c) there exist the corresponding cases in -y direction.

2.3. Nucleation of twin seeds

Twin nucleation occurs frequently during the growth process of mc-Si. The mechanism of twin nucleation for mc-Si crystal growth was proposed by Duffar et al. [28] and modified recently by Lan et al. [29]. The nucleation occurs at grooves with at least one $\langle 111 \rangle$ facet. Then a $\Sigma 3$ coherent twin boundary is formed. The probability of nucleation is given as a function of the local undercooling. On the meso-scopic scale we use such a probability for grain boundaries with facetted/facetted grooves. Experimetally, twin nucleation and subsequent creation of a $\Sigma 3$ coherent twin boundary was e.g. by Riberi et al. [9]. In this paper we restrict ourselves to describe the situation for the experiment described in [9].

When a cell becomes solid (ϕ becomes larger than 0.45) we apply a random generator and check if the random number is smaller than the (fixed) probability for nucleation. For a facetted/facetted groove nucleation can occur on one of the facets. In the experiment of [9] the nucleation always occured on the same side of the groove and thus we also take this side in our numerical calculations. Because it is twinning the orientation of the new grain is given by the one of the grain with the facet at the groove. The probabilities for nucleation is deduced from the experimental results, directly from the frequence of the occurence of a new twin boundary in the experiment.

2.4. High performance computation

The algorithms have been implemented into the software environment WaL-BErla [30, 31]. WalBErla is an object oriented toolbox, which ensures a high performance in massively parallel computing. The random generator of the standard C-Library was used. As the update of the grains is done via Monte Carlo procedure, we performed always several runs for a specific case choosing different initializations of the random generator. The resulting grain structures were comparable and we will show only the results of one run per case.

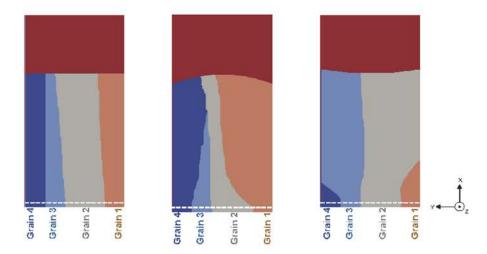


Figure 4: Evolution of grains for different crystal/melt interface shapes at 80% solidification. The angles between the main growth direction and the $\langle 100 \rangle$ orientation are 0°, -10° , 5°, and -5° for Grain 1, 2, 3, and 4, respectively. (a) Flat, (b) convex and (c) concave interface shape.

particular, for the cases discussed in this paper, the relative difference in area fraction of the various grains is less than 2%.

3. Calculations

3.1. Domain and thermal conditions

In all calculations we use a rectangular domain containing the silicon. No other parts of the furnace are currently included in the computations and realistic thermal boundary conditions need to be set. We try to mimic the typical process in a solidification experiment. In the real experiment the temperature is continuously reduced according to a cooling rate $\mathcal{R}_{\rm cool}$. This cooling rate is applied at the bottom boundary (x=0). The temperature gradient in the melt G_T^m is initially defined by setting the temperature at the top boundary via $T_{\rm bc}(t=0)=T_m+G_T^mx_{\rm int}$, where $x_{\rm int}$ is the position of the interface at t=0. The temperature at time t is given by $T_{\rm bc}(t)=T_{\rm bc}(t=0)-\mathcal{R}_{\rm cool}t$. The thermal boundary condition at bottom is set as follows: the incoming heat flux at t=0 is given by $\lambda^m G_T^m$ (λ^m is the heat conductivity in the melt). The outgoing heat flux corresponds to the incoming flux plus the one due to the latent heat production. The latter is given by $v_n^{\rm theor} \Delta H_V$, where $v_n^{\rm theor}$ is the theoretical growth velocity deduced from $v_n^{\rm theor} = \mathcal{R}_{\rm cool}/G_T^m$. Thus, the temperature gradient in the solid G_T^s is in a thermally steady-state situation:

$$G_T^s = \frac{\lambda^m}{\lambda^s} G_T^m + \frac{\Delta H_V}{\lambda^s} \frac{\mathcal{R}_{\rm cool}}{G_T^m} \quad = \quad \frac{D_T^m \rho^m c_p^m}{D_T^s \rho^s c_p^s} G_T^m + \frac{\Delta H_V}{D_T^s \rho^s c_p^s} \frac{\mathcal{R}_{\rm cool}}{G_T^m} \quad = \quad \frac{D_T^m}{D_T^s} G_T^m + \frac{\Delta H_V}{D_T^s \rho c_p} \frac{\mathcal{R}_{\rm cool}}{G_T^m}. \tag{7}$$

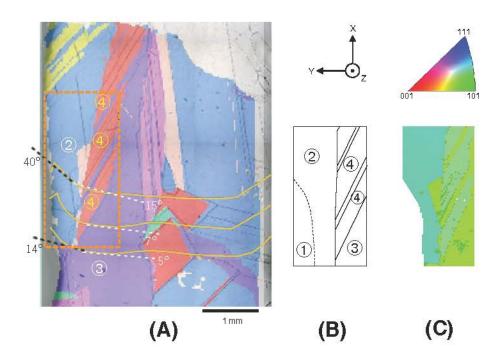


Figure 5: Experimental result of Riberi et al. [9]. (A) EBSD map in x-direction with interface lines (in yellow) from in-situ observation. (B) Part with simplification, which is revisited in numerical calculations. (C) EBSD map in z-direction, showing that all grains taken into account are almost oriented with the (101) plane in the cut. The labels \oplus to \oplus denote the different grains used in the numerical calculations.

Here, we assume $\rho^m c_p^m \equiv \rho^s c_p^s = \rho c_p$ for convenience¹. D_T , ρ , c_p are the thermal diffusivity, the density, and the heat capacity, respectively. m and s denote melt and solid, respectively. Thus, we set the heat flux at bottom according to Eq. 7:

$$j = D_T^m \rho c_p G_T^m + \Delta H_V \frac{\mathcal{R}_{\text{cool}}}{G_T^m}.$$
 (8)

¹In the vicinity of the melting point $\rho^s c_p^s = 2.45 \times 10^6 \ \mathrm{J\,m^{-3}K^{-1}}$ using data of [32]. For melt one has $\rho^s c_p^s = 2.65 \times 10^6 \ \mathrm{J\,m^{-3}K^{-1}}$ using data of [24] and [33] or $\rho^s c_p^s = 2.2 \times 10^6 \ \mathrm{J\,m^{-3}K^{-1}}$ when using the more recent data of [27]. Thus, the experimental uncertainties are of the same level as the difference in $\rho^m c_p^m$ and $\rho^s c_p^s = \rho c_p$.

3.2. Effects of the interface shape

Firstly, we studied the effect of the crystal/melt interface shape on the grain evolution in the solidification process with the given cooling rate and temperature gradient in the melt. As shown in Fig. 4, the computational domain is $25 \times 10 \text{ mm}^2$ descretized with a uniform grid with a spacing of $\Delta x = 5 \times 10^{-5} \text{ m}$. The time step is set to $\Delta t = 1.0 \times 10^{-3}$ s. The initial crystal/melt interface (in white dotted lines) is located at $x = 5 \times 10^{-4}$ m. Four grains are set at the bottom and grains grow towards upward (+ x-direction). The orientation variable is assigned to each grain, and the initial angles between the (100) orientation and the main growth direction are 0°, -10°, 5°, and -5° for grains 1, 2, 3, and 4, respectively. Fig. 4 shows the evolution of the grain structure under different crystal/melt interface shapes when the solidification fraction is 80%. An additional heat flux is set to the side boundaries of the domain to control the interface shape. The simulated results reveal that the crystal/melt interface shape significantly influences the grain evolution and grain distribution during the solidification process. For example, the crystal/melt interface shape is totally flat in Fig. 4(a) when heat fluxes at both side boundaries are zero. The GBs are almost straight lines for the flat interface shape in Fig. 4(a). While, for the convex and concave interface shapes, the GBs gradually change direction according to the orientation of the crystal/melt interface. As shown in Fig. 4(b), grains 2 and 4 gradually extend laterally, and finally stop the progress of grain 3, resulting in the formation of a new grain boundary. In the case of concave interface grains 2 and 3 prevail whereas grains 1 and 4 dissapear after a short time.

Please note that here we use some artifical input data for the grain boundary orientation as a function of the growth direction. An input based on phase field simulations will be presented in the second example. It is evident that both interfacial energies at the three phase junction and local growth kinetics determine the grain competition and result in different grain orientations for different growth directions. With the runs in this section we wanted to show that the interface shape might have a significant influence on the grain evolution.

Because the heat flux over the wall is only partly compensated by the adopted heat flux at bottom the growth velocities in the three runs are not exactly the same. In particular, it takes 28, 35, and 22 min to reach the 80% solidification of silicon for the case of flat, convex and concave interface shape, respectively. However, the input data for grain boundary orientations do not depend on growth velocity nor temperature gradient, and therefore this has no effect on the results of grain evolution.

3.3. Comparison with experiment

Mangelinck-Noël et al. have developed a method of in-situ observation of silicon solidification by means of X-ray synchrotron radiation [1]. This enables to track the crystal/melt interface during growth. Afterwards, this can be combined with the grain orientation analysis using electron beam scattering diffraction (EBSD). In this paper we compute the evolution of grains as observed in

an experiment by Riberi-Béridot et al. [9]. The cooling rate was $\mathcal{R} = 2$ K/min and the measured growth rate $v_n = 23 \mu \text{m/s}$. Thus, the temperature gradient in the melt can be estimated as $G_T^m = 14.5$ K/m (assuming $G_T^m = \mathcal{R}/v_n$).

Fig. 5(a) shows the EBSD map in the x-direction corresponding to the growth direction with interface lines (in yellow) from the in-situ observation. In the simulation, we consider a part of the experimental domain as indicated by the dashed orange lines in Fig. 5(a). The experimental sample has a ragged boundary because the melt did not continuously attached the curcible wall during the experiment. In the simulation the melt do attach always the domain wall. We also add a further grain on the left side (see (Fig. 5(B)) to demonstrate the influence of the interface shape, which is concave near the walls (see yellow lines in Fig. 5(A)). The computation domain is $16 \times 2.8 \text{ mm}^2$ discretized by a uniform grid of $\Delta x = 25 \ \mu \text{m}$. For the grain boundary between grains 2 and 3 as well as for @ and @ we set α_{grain} similar to the observed tilting in the experiment. The value is slightly varying with the interface shape. For the grain boundary between 3 and 4, i.e. the $\Sigma 3(111)$ boundary, we fix the value according to the experiment: $\alpha_{\text{grain}} = 25^{\circ}$. For the boundary between the artificially introduced grain ① and ②, we applied 2D phase field simulations as described in [34]. In Fig. 6 the results for different interface orientations are shown. It can be clearly seen that the angle of the grain boundary depends on the inclination of the interface. We set the values computed for the various inclinations of the interface.

The probabilities for twinning on the grains 3 and 4 are estimated from the lengths of the grain boundary between twinning events. The probability has to be given for the node distance $\Delta x = 25 \mu m$, i.e. for every update. It was estimated to be $P_{\text{update}} = 0.01875$ and $P_{\text{update}} = 0.0575$ for twinning on grain number 3 and 4, respectively. The probability to have a twin after a distance x is given by $1 - (1 - P_{\text{update}})^{x/\Delta x}$. It is 0.3, 0.4, and 0.6 for the twins on grain 3 and 0.25 and 0.4 for the twins on 4. For comparison we convert the probabilities P_{update} into those for a layer on a $\{111\}$ plane (layer distance is $d = 3.15 \times 10^{-10}$ m). Please note that the {111} plane has an angle of 30° with the growth direction and one layer in growth direction means a $\Delta x =$ 2.7×10^{-10} m. Thus, we obtain $\mathcal{P}_{twin} = 2.1 \times 10^{-7}$ and $\mathcal{P}_{twin} = 6.5 \times 10^{-7}$ for twinning on grain 3 and grain 4, respectively. These probabilities correspond to an undercooling of about 0.6 K according to the model of twin nucleation by Lin and Lan [29]. The same value was obtained for the undercooling in a facet/facet grain [34].

In the simulation we impose a similar temperature field as in the experiment and in particular a similar interface shape as in the experiment is computed. In order to get the interface shapes, we apply a heat flux $j_{\text{left}} = 0.15 j$ at the left boundary, where j is the heat flux at bottom (see Eq. 8). At the right hand side an adiabatic boundary condition is set as this boundary corresponds to position in the middle of the sample with nearly no curvature of the interface.

The evolution of the grain structure at different solidification stages is illustrated in Fig. 7(a-c). Please note that the colours of the grains are according to their numbering and do not reflect the orientation as in Fig. 7(d), where the

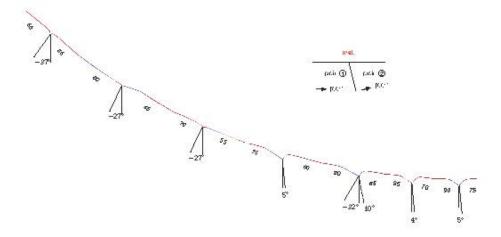


Figure 6: Results of the phase field calculations for the grain boundary between grain \odot and \odot for different orientations of the melt/solid interface. The colours at the interface represent the temperature (red: 1685 K, blue undercooled). The angles with respect to the main growth direction are given.

colour represents the orientation along the growth direction. The white dash line shows the initial interface position and the grains grow upward. As shown in Fig. 7(a) and (b), we could also track the variation of the crystal/melt interface shape. The concave interface shapes are similar with the experimental ones, although the curvature in the simulation is lower than that in the experiment. In addition, the final grain structure obtained in the computations is in good agreement with the experimental results of Riberi-Béridot et al. [9]. The occurrence frequency of twin nucleation is slightly higher than that in the experiment. Please note that twin nucleation is a statistical process and it cannot expected that the experimental result is exactly reproduced in the simulation. It is useful to compare statistical parameters, like grain orientation distribution. Since our simulation is based on 2D, it is unreasonable to compare the average grain size. Average grain size often gets from the statistics from the horizontal wafers. Here, we can compare the grain orientation distribution. We notice that Grain 2, 3 and 4 own unique orientation and the area fraction of them evolve differently along with the growth height in the growth direction. As show in Fig. 8, the relative error of area fraction for Grain ②, ③, and ④ between experiment and simulation at the end of solidification is 0.2%, 3.6% and 4.9%, respectively.

The grain boundary between grains \odot and \odot is a coherent $\Sigma 3(111)$ boundary. It can be described as a combined twist and tilt boundary with a transformation matrix (T matrix) of $T_{(111),1460}$ (see [35]). The grain boundaries between grains

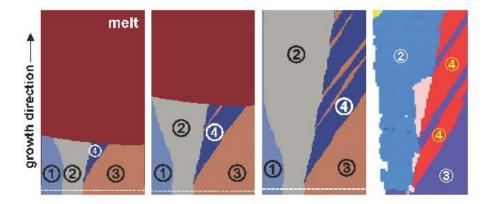


Figure 7: Results of grain structure during the solidification process. Numerical calculations at different stages of solidification: (a) 25%, (b) 50% and (c) 100%, and (d) experimental result of Riberi et al. [9].

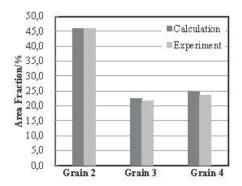


Figure 8: Area fraction of different grains at the end of solidification.

2 and 3 as well as between 2 and 4 are not coherent, which is reflected in slightly varying orientation of the grain boundaries. This effect is not yet included in our cellular automata setup.

The raw/processed data required to reproduce these findings cannot be shared at this time due to technical or time limitations.

4. Conclusions

We established a 2D model to calculate the evolution of grains based on input data from the microscopic scale simulations. In particular, the input data consists of the GB orientations with respect to the crystal/melt interface normal for every combination of GBs. It is shown that the interface shape significantly influences the grain evolution during the solidification process. In the case considered in this paper the GBs are almost straight for the flat interface shape,

while those gradually change with the variation of the interface normal for the convex and concave interface shapes. Nucleation of twin seeds is also investigated and compared with the experimental results. The calculated crystal/melt interface shape is similar to the experimental one. Moreover, the calculated grain morphology and orientation of GBs correspond with the observation in the experiments. The more input data for the CA model will be obtained by microscopic or atomistic calculations the more predective the CA model can be. In the future larger systems will be investigated, which will allow to make statistics on average grain size and orientation distributions.

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